L Number	Hits	Search Text	DB	Time stamp
1	211	(semiconductor near2 laser) and (optical adj2 (pick adj2 up)) and laser with (mount mounting holder holding base substrate support)	USPAT; EPO; JPO; IBM_TDB	2003/03/02 18:51
6	2	5689108.URPN.	USPAT	2003/03/02 17:34
7	2	("5285062" | "5374819").PN.	USPAT	2003/03/02 17:34
8	861	((372/36,109) or (369/44.12)).CCLS.	USPAT	2003/03/02 17:48
9	833	(((372/36,109) or (369/44.12)).CCLS.) not ((semiconductor near2 laser) and (optical adj2 (pick adj2 up)) and laser with (mount mounting holder holding base substrate support))	USPAT; EPO; JPO; IBM_TDB	2003/03/02 17:49
24	592	(((372/36,109) or (369/44.12)).CCLS.) and (laser with (mount base substrate holder case))	USPAT; EPO; JPO; IBM_TDB	2003/03/02 18:33
29	0	6459710.URPN.	USPAT	2003/03/02 17:53
30	10	("3698789" | "4844581" | "4945391" | "5245620" | "5631987" | "5812715" | "5920585" | "6094515" | "6243517" | "6345059").PN.	USPAT	2003/03/02 17:54
31	3	5748658.URPN.	USPAT	2003/03/02 18:26
32	14	("4589010" | "4768070" | "4888307" | "4945524" | "5082339" | "5089861" | "5140572" | "5291038" | "5293038" | "5309460" | "5327443" | "5361244" | "5367530" | "5446719").PN.	USPAT	2003/03/02 18:27
33	14	("4589010" | "4768070" | "4888307" | "4945524" | "5082339" | "5089861" | "5140572" | "5291038" | "5293038" | "5309460" | "5327443" | "5361244" | "5367530" | "5446719").PN.	USPAT	2003/03/02 18:27
34	37	(ohyama tanaka).in. and (optical adj2 (pick adj2 up))	USPAT; EPO; JPO; IBM_TDB	2003/03/02 18:48
39	7	(fukada).in. and pioneer.as.	USPAT; EPO; JPO; IBM_TDB	2003/03/02 18:47
44	1630	pioneer.as. and laser	USPAT; EPO; JPO; IBM_TDB	2003/03/02 18:47
49	13	(pioneer.as. and laser) and fukuda.in.	USPAT; EPO; JPO; IBM_TDB	2003/03/02 18:47
54	42	(pioneer.as. and laser) and (optical adj2 (pick adj2 up))	USPAT; EPO; JPO; IBM_TDB	2003/03/02 18:48
59	173	(semiconductor near2 laser) and (optical adj2 (pick adj2 up)) and case and ((mount base substrate support holder) with laser)	USPAT; EPO; JPO; IBM_TDB	2003/03/02 19:11
64	0	6208610.URPN.	USPAT	2003/03/02 19:00
65	0	6208610.URPN.	USPAT	2003/03/02 19:00
66	4	6172958.URPN.	USPAT	2003/03/02 19:03
67	1477	(semiconductor near2 laser) with module	USPAT; EPO; JPO; IBM_TDB	2003/03/02 19:11
77	365	((semiconductor near2 laser) with module) and (casing case) and optical near3 system	USPAT; EPO; JPO; IBM_TDB	2003/03/02 19:13
82	6	(((semiconductor near2 laser) with module) and (casing case) and optical near3 system) and optical adj2 (pick adj2 up)	USPAT; EPO; JPO; IBM_TDB	2003/03/02 19:13

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